



Docket No.: 052775-0024

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of	:	Customer Number: 20277
	:	
Masahiro NAKAYAMA, et al.	:	Confirmation Number: 1716
	:	
Application No.: 10/662,524	:	Group Art Unit: 3723
	:	
Filed: September 16, 2003	:	Examiner: Dung V. Nguyen
	:	

For: CHAMFERED FREESTANDING NITRIDE SEMICONDUCTOR WAFER AND  
METHOD OF CHAMFERING NITRIDE SEMICONDUCTOR WAFER

**AMENDMENT**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The following Amendment and Remarks are submitted in response to the non-final  
Office Action dated March 15, 2006.

**Amendments to the Claims** begin on page 2.

**Remarks** begin on page 5.